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PATENT  
Customer No. 22,852  
Attorney Docket No. 2887.0259-00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

|                             |   |                            |
|-----------------------------|---|----------------------------|
| In re Application of:       | ) |                            |
|                             | ) |                            |
| Junji SUGAMOTO et al.       | ) | Group Art Unit: 2891       |
|                             | ) |                            |
| Application No.: 10/706,090 | ) | Examiner: LEE, Granvill D. |
|                             | ) |                            |
| Filed: November 13, 2003    | ) |                            |
|                             | ) |                            |
| For: SEMICONDUCTOR WAFER    | ) | Confirmation No.: 7292     |
| TREATMENT METHOD,           | ) |                            |
| SEMICONDUCTOR WAFER         | ) |                            |
| INSPECTION METHOD,          | ) |                            |
| SEMICONDUCTOR DEVICE        | ) |                            |
| DEVELOPMENT METHOD AND      | ) |                            |
| SEMICONDUCTOR DEVICE        | ) |                            |
| TREATMENT APPARATUS         | ) |                            |

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TWO MONTHS TIME**

Applicants petition for a two month extension of time to reply to the Office Action of March 23, 2005. A fee of \$450.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

*Richard V. Burgujian*

450.00 OP

Dated: August 23, 2005

By: *Richard V. Burgujian* #27,832  
Richard V. Burgujian  
Reg. No. 31,744